

## PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/611,037  
Applicant: : Kuthi, et al.  
Filed: : July 6, 2000  
Title: : METHOD FOR IMPLEMENTING A  
SEMICONDUCTOR PROCESS CHAMBER  
ELECTRODE  
  
TC/A.U. : 1763  
Examiner : Alejandro Mulero, L.  
  
Atty. Docket No. : LAM1P077A  
Date: : September 4, 2003

## CERTIFICATE OF FACSIMILE

I hereby certify that this paper and the documents referred to as attached thereto are being transmitted by facsimile on September 4, 2003 to the United States Patent & Trademark Office, Attention Luz ALEJANDRO, Technology Center 1700, Alexandria, VA 22313-1450, to facsimile number 703-872-9311

Signed: \_\_\_\_\_

Neely Jo Entwistle

Commissioner for Patents  
Alexandria, VA 22313-1450

## RESPONSE

Sir:

Applicants submit this paper in response to the Final Office Action dated June 04, 2003. The period for response extends to September 04, 2003. Please enter the following amendments and remarks:

The Listing of Claims begins on page 2 of this paper.

Remarks/Argument begins on page 8 of this paper.

Declaration Under 37 CFR §1.132 is attached as Appendix A to this paper.

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